



**INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION**  
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PTO Form 1449

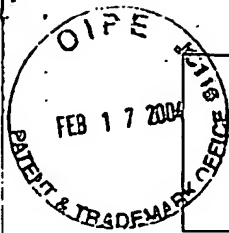
Atty Docket No. 112857-315	Application No. 10/062,776
Applicant Yoshiyuki Yanagisawa et al.	
Filing Date 01/30/2002	Group 2812

U.S. PATENT DOCUMENTS						
Examiner's Initials	Document Number	Publication Date	Inventor	Class	Subclass	Filing Date If Appropriate
SJM	5,177,405	01/05/1993	Kusuda et al.			
	5,206,749	04/27/1993	Zavracky et al.			
	5,258,320	11/02/1993	Zavracky et al.			
	5,438,241	08/01/1995	Zavracky et al.			
	5,739,800	04/14/1998	Lebby et al.			
GM	5,981,977	11/09/1999	Furukawa et al.			

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Examiner's Initials	Document Number	Publication Date	Country	Class	Subclass	Translation	
						Yes	No
SJM	56-17385 ✓	02/19/1981	Japan				
	56-92577 ✓	07/27/1981	Japan				
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	58-50577 ✓	03/25/1983	Japan				
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	04-247486	09/03/1992	Japan				
GM	05-290669 ✓	11/05/1993	Japan				
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	6-45648	02/18/1994	Japan				
	06-067044	03/11/1994	Japan				
	06-504139	05/12/1994	Japan				

Examiner: SJM Date Considered: 3/16/02

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Examiner's Initials	Document Number	Publication Date	Country	Class	Subclass	Translation	
						Yes	No
GM	WO 95-05623	02/23/1995	PCT				
	07-199829	04/08/1995	Japan				
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	07-263754	10/13/1995	Japan				
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	11-514136	11/30/1999	Japan				

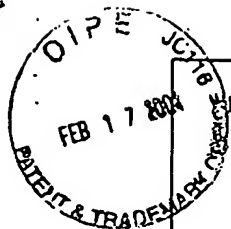
Examiner:

*S. A. ...*

Date Considered:

2/11/02

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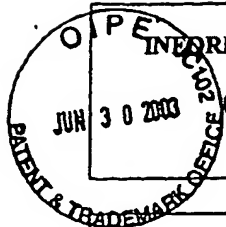


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Examiner's Initials	Document Number	Publication Date	Country	Class	Subclass	Translation	
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Gm	11-346004	12/14/1999	Japan				
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	2000-89693	03/31/2000	Japan				
	2000-183451	06/30/2000	Japan				
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Gm	Zheleva et al., "Pendeo/Epitaxy - A New Approach For Lateral Growth Of Gallium Nitride Structures", MRS Internet J. Nitride Semicond. Res. 4S1, G3.38 (1999).
Gm	Kapolnek et al., "Spatial Control Of InGaN Luminescence By MOCVD Selective Epitaxy, Journal Of Crystal Growth", 189/190 (1998) pp. 83/86.
Gm	Applied Physics Letters, Vol. 76, Number 22, 29 May 2000, "Selective Growth Of InGaN Quantum Dot Structures And Their Microphotoluminescence At Room Temperature", Tachibani et al, pages 3212/3214

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	A1						
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						
	A12						

FOREIGN PATENT DOCUMENTS								
Examiner's Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No
SM	A13	JP 5-315646	11/26/1993	Japan				
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	A15							
	A16							
	A17							
	A18							
	A19							
	A20							

Examiner's Initials		OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
	A21	
	A22	
	A23	
	A24	
	A25	

Examiner: <u>S. M. [Signature]</u>	Date Considered: <u>12/15/03</u>
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